Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L3	1615	laser and ((distributed near3 feedback) or dfb) and (contact near3 layer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/19 11:26
L4	444	laser and ((distributed near3 feedback) or dfb) same (contact near3 layer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/19 13:01
L6	3	(("6977953") or ("20030020079")). PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/19 13:32
L10	887	laser and (((dielectric or semiconductor) near film) and ((index near3 refraction) and (refractive near3 index)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/19 14:09
L11	5094	laser and (((dielectric or semiconductor) and film) and ((index near3 refraction) and (refractive near3 index)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/19 14:09
L12	4989	laser and (((dielectric or semiconductor) and film) and ((index near refraction) and (refractive near index)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/19 14:10
L13	4928	laser and (((dielectric or semiconductor) and film) and ((index near refraction) and (refractive near index)))	US-PGPUB; USPAT	AND	ON	2006/01/19 14:10
L14	1842	laser and (((dielectric or semiconductor) and film) and ((index near refraction) and (refractive near index)))	US-PGPUB	AND	ON	2006/01/19 14:10

L15	24	("5070510" | "5272109" | "5282218" | "5319661" | "5426658" | "5470786" | "5610096" | "5960019" | "5966396" | "5970080" | "5978402" | "5990496" | "6064079" | "6185238" | "6215803" | "6323507" | "6359919" | "6387721" | "6400742" | "6522676" | "6534800" | "6567449" | "6580736" | "6614059").PN.	US-PGPUB; USPAT; USOCR	AND	ON	2006/01/19 14:13
S1	225	((equivalent adj refractive adj index) or (equivalent near index near3 refration)) and substrate and laser and (contact near3 layer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/19 08:50
S2	68	((equivalent adj refractive adj index) or (equivalent near index near3 refration)) and edge and laser and (contact near3 layer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/13 15:07
S3	3	((equivalent adj refractive adj index) or (equivalent near index near3 refration)) and edge-emitting and laser and (contact near3 layer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/13 11:55
S4	12	("20020037022" | "20020122615" | "5386428" | "5528614" | "5563094" | "5585957" | "5606570" | "5889805" | "6396863" | "6560261" | "6567444" | "6580738").PN.	US-PGPUB; USPAT; USOCR	AND	ON	2006/01/13 15:10
S5	894	(luminous near3 (wavelength or wave near length)) and laser	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/17 12:05
S6	894	((luminous near3 (wavelength or wave near length)) and laser) or (((luminous near3 (wavelength or wave near length)) and laser) and (equasion or equation or refractive adj index))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/17 16:22
S17	0	".sub.2"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/17 16:19

S18	0	".sup.2"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/17 16:19
S19	327	((luminous near3 (wavelength or wave near length)) and laserand (equasion or equation)) or (((luminous near3 (wavelength or wave near length)) and laser) and (equasion or equation or refractive adj index))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/17 16:28
S20	327	((luminous near3 (wavelength or wave near length)) and laser and (equasion or equation)) or (((luminous near3 (wavelength or wave near length)) and laser) and (equasion or equation or refractive adj index))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/17 16:28
S21	934	(372/43.01).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/18 08:25
S22	1979	(372/45.01).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/18 16:50
S23	0	laser and ((dielectric or semiconductor) near film and ((index near3 refration) and (refractive near3 index)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/18 16:53
S24	885	laser and ((dielectric or semiconductor) near film and ((index near3 refraction) and (refractive near3 index)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/19 13:52
S25	77	laser and (((dielectric or semiconductor) near film) same ((index near3 refraction) and (refractive near3 index)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/01/19 13:58